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TO: U.S. Patent & Trademark Office
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DATE: February 3, 2004

FROM: Eugene J. Bernard, Esq.
Hogan & Hartson LLP
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MESSAGE:**FOR INTERNAL PURPOSES ONLY**TELECOPY/FAX NUMBER: 703.872.9306CLIENT NUMBER: 81848.0016.001ATTORNEY BILLING NUMBER: 73049

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Serial No. 09/546,174
Application of: Chih-Chien LIU, et al.
Filed: April 11, 2000
Art Unit: 1711
Examiner: R.A. SERGENT
Attorney Docket No. UMC-96-279 CON
For: HIGH DENSITY PLASMA CHEMICAL VAPOR DEPOSITION PROCESS
Confirmation No.: 4793
Customer No.: 25235

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1. Amendment and Response to the Office Action Mailed December 23, 2003; and
2. Amendment Fee Transmittal Form (2 copies)

On February 3, 2004

to centralized fax number: 703-872-8306



Daniel J. Stephenson

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FEB 11 2004
OFFICIALAttorney Docket No. UMC-96-279 CON
Client Matter No. 81848.0016.001

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| Serial No. 09/546,174 Application of: LIU, Chih-Chien <i>et al</i> Filed: April 11, 2000 Art Unit: 1711 Examiner: SERGENT, R.A. Attorney Docket No. UMC-96-279 CON For: HIGH DENSITY PLASMA CHEMICAL VAPOR DEPOSITION PROCESS | Confirmation No.: 4793 Customer No.: 25235 |
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AMENDMENT AND RESPONSE TO THE OFFICE ACTION
MAILED DECEMBER 23, 2003Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

An Office Action was mailed in the above case December 23, 2003.

Please reconsider the case in light of the amendment and remarks that follow.

Amendments to the Claims are reflected in the listing of claims, which begins on page 2 of this paper.**Remarks** begin on page 9 of this paper.